

Notice of References Cited	Application/Control No. 10/706,460	Applicant(s)/Patent Under Reexamination KIM ET AL.
	Examiner Hai L. Nguyen	Art Unit 2816

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*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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